

Application/Control No.	Applicant(s)/Patent under Reexamination
10/763,765	DIRSCH ET AL.
Examiner	Art Unit
Rina I. Duda	2837

SEARCHED					
Class	Subclass	Date	Examiner		
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INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)			
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